



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)			
	: Examiner: K. Fernandez			
Masato MURAKI et al.)			
	: Group Art Unit: 2881			
Application No.: 09/708,590)			
	: Allowed: October 28, 2002			
Filed: November 9, 2000)			
E CORRECTING METHOD FOR	: Confirmation No.: 2106			
For: CORRECTING METHOD FOR)			
CORRECTING EXPOSURE DATA USED	: January 28, 2003	=		
FOR A CHARGED PARTICLE BEAM)	5		
EXPOSURE SYSTEM	:	旁		-71
		RECHNOLOGY.	JEN	RECEIVED
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Commissioner for Patents		CENTER		
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Washington, D.C. 20231			ದ	0
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PRELIMINARY AMENDMENT

Sir:

Prior to further examination on the merits, please amend the above-identified application as follows:

IN THE SPECIFICATION:

Please amend the specification as follows:

Please substitute the paragraph beginning at page 6, line 9, and ending on page 7, line 11, with the following. A marked-up copy of this paragraph, showing the changes made thereto, is attached in Appendix A.